

ABSTRACT

MANUFACTURING METHOD OF GLASS SUBSTRATE FOR MAGNETIC DISC,
GLASS SUBSTRATE FOR MAGNETIC DISC,
AND MAGNETIC DISC

A manufacturing method of a glass substrate 100 for a magnetic disc according to the present invention includes a substrate condition measuring step S200; a defect inner surface position specifying step S202; a surface defect judging step S204 for judging whether or not a defect with specified inner surface position is on the surface of the glass substrate 100 on the basis of the number of images formed at an inner surface position by an image forming means; and the non-defective judging step S206 for judging whether or not the glass substrate 100 is non-defective on the basis of a result of the surface defect judging step S204.

(FIG. 2)